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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

BU, DONE

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2002-38977 07/05/2002

BU, YES

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>BU</u> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 2	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 2
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## TITLE

Method for forming metal silicide layer in active area of semiconductor device

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